## Notice of References Cited Application/Control No. | Applicant(s)/Patent Under Reexamination | YIN ET AL. | Examiner | Art Unit | Page 1 of 1

## **U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	Α	US-6,841,341	01-2005	Fairbairn et al.	430/323
*	В	US-2004/0092098	05-2004	Sudijono et al.	438/637
*	С	US-2003/0198814	10-2003	Khieu et al.	428/412
*	D	US-5,830,332	11-1998	Babich et al.	204/192.15
*	Ε	US-6,795,636	09-2004	Cronk et al.	385/141
*	F	US-5,470,661	11-1995	Bailey et al.	428/408
	G	US-			
	Н	US-			
	ı	US-			
	J	US-			
	К	US-			
	٦	US-			
	М	US-			

## **FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	0					
	Р					
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	R					
	s					
	T					

## **NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)			
	U	Lide, David R., ed., CRC Handbook of Chemistry and Physics, Internet Version 2005, http://www.hbcpnetbase.com, CRC Press Boca Raton, FL, 2005, pg. 12-157.			
	V	He et al., Characterization and optical properties of diamondlike carbon prepared by electron cyclotron resonance plasma, J. Mater. Res., 14(3) (Mar 1999) 1055.			
	w	Zhou et al., Deposition and properties of a-C:H films on polymethyl methacrylate by electron cyclotron resonance microwave plasma chemical vapor deposition method, Surface and Coatings Technology, 123 (2000) 273.			
	х	Chen et al., Optical constants of tetrahedral amorphous carbon films in the infrared region and at a wavelength of 633 nm, J. Appl. Phys., 87(9) (May 2000) 4268.			

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)

Dates in MM-YYYYY format are publication dates, Classifications may be US or foreign.